

**Notice of References Cited**

Application/Control No.

10/811,490

Applicant(s)/Patent Under  
Reexamination  
CHO ET AL.

Examiner

William C. Dowling

Art Unit

2851

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,824,270	11-2004	Kim et al.	353/31
*	B	US-6,771,325	08-2004	Dewald et al.	348/743
*	C	US-6,642,969	11-2003	Tew, Claude E.	348/743
*	D	US-6,619,802	09-2003	Janssen et al.	353/31
*	E	US-6,591,022	07-2003	Dewald, D. Scott	382/274
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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